

High Photoresponsivity in Graphene Nanoribbon Field Effect Transistor Devices Contacted With Graphene Electrodes

Andrea Candini, Leonardo Martini, Zongping Chen, Neeraj Mishra, Domenica Convertino, Camilla Coletti, Akimitsu Narita, Xinliang Feng, Klaus Müllen, and Marco Affronte

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20 *Andrea Candini*^{1*}, *Leonardo Martini*^{1,2}, *Zongping Chen*³, *Neeraj Mishra*⁴, *Domenica*
21 *Convertino*⁴, *Camilla Coletti*⁴, *Akimitsu Narita*³, *Xinliang Feng*⁵, *Klaus Müllen*³ and *Marco*
22 *Affronte*^{2,1}
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28 ¹Centro S3, Istituto Nanoscienze - CNR, via G. Campi 213/A , 41125 Modena. Italy.
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30

31 ²Dipartimento di Scienze Fisiche, Matematiche e Informatiche, Università di Modena e Reggio
32 Emilia via G. Campi 213/A , 41125/A Modena. Italy.
33
34
35
36

37 ³Max Planck Institute for Polymer Research, Ackermannweg 10, D-55128 Mainz, Germany.
38
39

40 ⁴Center for Nanotechnology Innovation @ NEST, Istituto Italiano di Tecnologia, Piazza San
41 Silvestro 12, 56127 Pisa, Italy
42
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44
45

46 ⁵Center for Advancing Electronics Dresden (cfaed) & Department of Chemistry and Food
47 Chemistry, Technische Universität Dresden, 01062 Dresden, Germany
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3 KEYWORDS: graphene nanoribbons, graphene contacts, field-effect transistor, high sensitivity
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12 ABSTRACT
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16 Ultra-narrow graphene nanoribbons (GNRs) with atomically precise structures are considered a
17 promising class of materials for the realization of optoelectronic and photonic devices with
18 improved functionalities. Here we report the opto-electronic characterization of a field effect
19 transistor devices made of a layer of bottom-up synthesized GNRs contacted with multilayer
20 graphene electrodes, showing high photoresponsivity of 5×10^5 A/W for small incident power in
21 the visible-UV range. Our results show that combining the properties of intrinsic graphene with
22 that of semiconducting GNRs is a viable route to realize novel devices for optoelectronic and
23 sensing applications.
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38 1. INTRODUCTION
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41 Graphene nanoribbons (GNRs) are narrow stripes of graphene, where quantum confinement
42 induces a bandgap in the electronic structure, which can be precisely engineered by tailoring their
43 size and morphology^{1,2}. Although GNRs have been obtained by several techniques, including
44 patterning of graphene³ and unzipping of carbon nanotube^{4,5}, only bottom-up approaches, such as
45 surface-assisted⁶⁻⁹ and solution-mediated^{10,11} synthesis, offer the degree of structural control
46 needed to determine their optical and electronic properties. Particularly appealing is their
47 integration in optoelectronics devices¹², to fully exploit the presence of a direct bandgap. In
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3 addition, the appearance of novel features related to the GNR one-dimensional character has been
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5 predicted, including strong excitonic effects that may lead to enhanced light absorption and
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7 amplification¹³⁻¹⁵. However, optoelectronic devices made of bottom-up GNRs have so far been
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9 limited to a moderate light response¹⁶, likely as a consequence of the relatively high series
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11 resistances of these devices, spoiling the intrinsic properties of the GNRs.
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17 Graphene can be efficiently employed as transparent electrodes¹⁷ and as the contact material for
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19 other low-dimensional systems, such as transition metal dichalcogenides¹⁸⁻²⁰. In particular, so-
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21 called *all-graphene* devices have been recently proposed²¹, suggesting that the graphene/GNR
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23 junction can be suitable to make good electrical contacts eventually leading to better performances
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25 than conventional semiconductor-metal devices. In this context, we have recently shown that the
26
27 use of graphene electrodes to inject current in a layer of surface-synthesized chemical vapor
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29 deposition (CVD) -grown GNRs is suitable to realize short channel devices (100 - 200 nm)
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31 showing high ON-state currents and field-effect transistor (FET) behavior⁹.
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37 Here we demonstrate the sensitive phototransistor performances of our *all-graphene* devices,
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39 where the channel is made of a layer of structurally defined GNRs⁹ and the source / drain electrodes
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41 are made of multilayer epitaxial graphene (MEG) grown on the C face of SiC²². The large optical
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43 bandgap of the GNRs (~1.8 eV) enables field-effect transistor (FET) operations as well as light
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45 absorption and photocurrent generation. Due to the good matching between the graphene
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47 electrodes and the flat layer of the CVD-grown GNRs⁹, carriers and photo-generated carriers are
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49 efficiently extracted from the devices resulting in high current on/off ratios and enhanced
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51 photosensitivity. Our devices show a gate-tunable photocurrent with a photoresponsivity
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3 approaching $\sim 10^6$ A/W in the broad visible-UV range for incident power below 1 pW. As a
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5 consequence the devices show the capability to detect signals down to the sub-fW range.
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8 9 10 2. EXPERIMENTAL SECTION

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12 **2.1. Fabrication of the graphene electrodes.** Multilayer epitaxial graphene devices were
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14 obtained on on-axis SiC(000-1) semi-insulating wafer dice following a previously reported
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16 procedure²³⁻²⁴. We determine an average thickness of 5 graphene layers by Raman spectroscopy
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18 (see Supporting Information Figure S1)^{23,35}. The devices are realized by electron beam
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20 lithography, metal (Cr/Au) evaporation and oxygen plasma etching to pattern the device geometry
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22 and to realize the gap of about 100-200 nm. We remark that pristine graphene devices (described
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24 in the Supporting Information Figures S2-S4) show a very small gate dependence (< 10% of
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26 current modulation) with signature of ambipolar and no detectable light induced current.
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33 **2.2. GNR synthesis and transfer.** Structurally defined chevron-type GNRs with well-defined
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35 edge structure (see inset of Figure 1a) have been grown from 6,11-dibromo-1,2,3,4-
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37 tetraphenyltriphenylene as the monomer by the ambient pressure CVD method under a mixture of
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39 Ar and H₂, following a reported procedure⁹ on a gold/mica substrate. Briefly, in a horizontal tube
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41 furnace (Nabertherm, RT 80-250/11S), the monomer was sublimed at 250–325 °C with a heating
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43 belt (Thermocoax Isopad S20) onto the Au/mica substrate, which was maintained at 200–250 °C
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45 under gas flow of Ar (500 s.c.c.m.) and H₂ (100 s.c.c.m.). After heating at the same temperatures
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47 for another 5–30 min, the substrate was further annealed at 400–450 °C for 15 min. More details
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49 on the synthesis are given in Figures S5-S6 of the Supporting Information. The GNR layers have
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51 been comprehensively characterized through Raman spectroscopy, X-ray photoelectron
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3 spectroscopy (XPS), high-resolution electron energy loss spectroscopy (HREELS) and scanning
4 tunneling microscopy, which corroborated their high quality comparable to the GNRs fabricated
5 under the UHV conditions^{6,9}.
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10 The final devices are obtained by transfer the resulting GNR film on the pre-fabricated MEG
11 electrodes without further fabrication (lithography) processes. The transfer process is performed
12 according to the following procedure⁹: the sample is spin coated with a PMMA thin film as a
13 mechanical support. The immersion in a hydrofluoric acid (HF) (40 wt. %) solution for several
14 hours etch the mica away; after this step the samples are cleaned in ultrapure water; the gold film
15 is removed by a commercial gold etchant (Sigma-Aldrich), leaving the GNR/PMMA film floating
16 on water surface, which is then transferred on the new substrate with graphene electrodes. The
17 PMMA film is finally removed with hot acetone and the sample is cleaned in isopropyl alcohol.
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28 Figure 1b shows a scanning electron microscope (SEM) image of a typical device after
29 fabrication.
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35 **2.3. Electrical characterization and measurements.** All the electrical measurements have
36 been realized in a 4-probe station (LakeShore PS-100) at the pressure of 10^{-4} torr. When not
37 specified, the sample is kept at room temperature. The electrical characterization is performed with
38 a Keithely 2636 source meter in the two-probes configuration. The illumination of the sample with
39 white light is realized with a halogen lamp while for monochromatic light we employed a Quartz
40 Tungsten Halogen lamp operated at up to 220 V and a diffraction grating monochromator working
41 between 350 and 800 nm. In both cases, light is directed to the sample through a microscope 70x
42 objective resulting in an uniform illuminated area. The incident light intensity is measured with a
43 commercial Oriel photodiode over an area of 1cm^2 .
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3. RESULTS AND DISCUSSIONS

3.1. Electrical characterization. Typical electrical characteristics of the devices are shown in Figure 2a,b. Measurements are performed at room temperature and under vacuum (10^{-4} torr), while the whole area of the device is illuminated by a white lamp. Figure 2a shows the transfer characteristics (source-drain current I_{sd} vs gate voltage V_g) for different bias (source-drain) voltages V_{sd} . The device displays an n-type semiconductor-like behavior, as also found for metal contacted GNRs²⁶, and the current saturates for positive gate voltages. The non-linear shape of the I_{sd} - V_{sd} characteristics shown for various V_g values (Figure 2b) and the asymmetry between negative and positive bias indicate non-Ohmic contacts, a common issue for bottom-up GNR devices^{9,16,26}. We note the relatively high ON-state current value ($I_{sd} > 10$ nA for $V_{sd} \sim 1$ V) that we ascribe to the reduced contact resistance at the GNR/graphene interface⁹. This leads to a high ON/OFF current modulation up to $\sim 10^4$ for $V_{sd} = -0.5$ V.

3.2. Photoconductive properties. We now turn to the photoconductive properties of our devices. The light-dependence of the output current is described in Figure 3a, where the I_{sd} - V_{sd} characteristics with $V_g = 0$ V are presented with and without illumination (white lamp with measured intensity of 3.6 mW/cm² at 550 nm). The presence of light induces a strong increase in I_{sd} , doubling its value for $V_{sd} > 1$ V. The generated photocurrent ($I_{photo} = I_{light} - I_{dark}$) has a non-linear dependence on the source bias and can exceed several tens of nA, that is at least one order of magnitude more than previous GNR-based (with metallic electrodes) devices¹⁶, for similar bias and incident illumination intensity. Figure 3b provides the dependence of the photocurrent on the gate voltage, where for each gate value the current is first measured under illumination and then

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3 in the dark. We found that the photo-generated current is strongly gate dependent, which may be
4 important for practical applications where an electrically tunable light-induced output is required.
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6 The illumination induces an increase of the current for all the gate values, except for large negative
7 gate voltages ($V_g < -30$ V, i.e. when the device operates in the OFF state) where the light effect
8 becomes negligible. The inset of Figure 2b displays the $I_{\text{light}} / I_{\text{dark}}$ ratio which is always > 1 and
9 for this particular sample was as high as ~ 10 for $V_g = -10$ V. Interestingly, both I_{light} and I_{dark}
10 saturate for the same gate voltage values, ruling out the photogating effect as the dominant
11 mechanism at the origin of the observed behavior^{27,28}.
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24 **3.3. Photocurrent dependence on the incident power and wavelength.** Further insights into
25 the photoconductive behavior of the devices can be obtained by studying the dependence of the
26 photocurrent on the photon wavelength λ and the incident power P_{inc} (Figure 4 a and b). The
27 normalized photoresponsivity (i.e. the photocurrent divided by the incident power $I_{\text{photo}} / P_{\text{inc}}$
28 normalized setting the value at 550 nm to 1) is given in Figure 4a for different incident photon
29 wavelengths. The photoresponsivity is negligible for $\lambda > 650-700$ nm, and then it increases
30 monotonously with decreasing λ without sign of saturation down to 380 nm. The onset at 650-700
31 nm corresponds to a photon energy of ~ 1.8 eV. The wavelength dependence of the
32 photoresponsivity perfectly matches the UV-vis-NIR absorption spectra of the CVD-GNR films
33 transferred on fused silica⁹ (see also Figure S5b of the Supporting Information). These
34 observations indicate that light-absorption by the GNRs is the most important mechanism for the
35 photo-induced behavior, excluding other possible effects such as simple heating (see also Figure
36 S8 of the Supporting Information). Figure 4b shows the dependence of the photocurrent on the
37 illumination intensity. Here we employed a monochromatic light ($\lambda = 550$ nm) fixing V_{sd} and V_g
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3 to 1 V and 0 V, respectively. Notably, a direct measurement of a signal as small as 10^{-3} W/m² was
4 possible, demonstrating the high sensitivity of our devices. The photocurrent displays a sublinear
5 behavior and tends to saturate when the light intensity is above 10 W/m².
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12 Based on these observations, we propose a simple model for the operation of the devices as
13 depicted in Figure 4c. Considering only the essential features of the device, the GNR film channel
14 is schematically represented by the energy band structure of a homogenous semiconductor, and
15 the MEG electrodes are represented by the band structure of one graphene layer^{23,29}. To account
16 for the non-linearity and the asymmetry of the I_{sd} - V_{sd} curves shown in Figure 2, we consider the
17 presence of a Schottky-type barrier at the main interface between the GNR film and the graphene
18 electrodes. The relatively high contact resistance can also explain the current saturation observed
19 for $V_g > 0$ V, where the electric field is no longer effective in tuning the device intrinsic resistance³⁰.
20 Ohmic contacts with low resistances have been reported for MoS₂ devices¹⁸⁻²⁰ using monolayer
21 graphene as the electrode, exploiting its electrically tunable workfunction. This effect is possibly
22 masked in our devices by the use of multilayer graphene with weak gate dependence (Figure S4
23 of the Supporting Information). On the other hand, we can safely ascribe the observed field effects
24 to the GNR film only.
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42 When $V_g \geq 0$ V, the Fermi level of the MEG electrode is aligned with the conduction band of the
43 GNRs and the current flows through the device upon the application of a bias voltage via
44 thermoionic and tunnel effects (Figure 4c-left). Illuminating the sample with a light source of
45 energy greater than the optical bandgap of the GNR film (1.8 eV) results in an increase of the
46 current, because of the photo-induced generation of electron-hole pairs in addition to the
47 promotion of carriers across the barrier (Figure 4c-center). Both mechanisms become more
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3 efficient as the photon energy is increased, explaining the observed photocurrent dependence on
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5 λ . The extraction of the photo-generated carriers through the barrier is assisted by the application
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7 of a finite source-drain bias, resulting in the nonlinear dependence of I_{photo} versus V_{sd} . Lowering
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9 the gate voltage causes an increase of the interface barrier and the depopulation of the carrier in
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11 the GNR channel. When $V_{\text{g}} < -30$ V, the device is turned off and no current is flowing with or
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13 without illumination (Figure 4c-right). The sublinear dependence of I_{photo} versus incident power
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15 indicates a saturation of the available states for the photo-generated pairs and a decrease of the
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17 carrier extraction efficiency.
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24 **3.4. Estimation of the photoresponsivity.** We now proceed to the quantitative evaluation of the
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26 light response of our devices. One of the most important parameters for a photosensitive device is
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28 its external photoresponsivity R defined as the ratio between the photo-induced current and the
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30 incident light power. To determine P_{inc} we need to estimate the device active area, which in our
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32 case is given by the GNR layer channel plus the contacts region with the multilayer graphene
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34 electrodes. Taking into account that no measurable light induced signal was observed in the
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36 pristine multilayer graphene (see Supporting Information Figure S3), we estimate as an upper limit
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38 of the device active area the square of $1\mu\text{m} \times 1\mu\text{m}$ shown in Figure 1b. This leads to the calculated
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40 R given in Figure 5a as a function of the incident power. The photoresponsivity increases as the
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42 incident power is reduced, and at low incident power ($< 10^{-14}$ W) the device possesses a remarkably
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44 high photoresponsivity of $\sim 5 \times 10^5$ A/W, fixing the bias and gate voltage at 1 V and 0 V,
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46 respectively. To estimate the sensitivity of our device, i.e. the noise equivalent power (NEP), we
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48 measured the current noise in the dark state, fixing $V_{\text{g}} = -10$ V (where the $I_{\text{light}} / I_{\text{dark}}$ ratio is
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50 maximum), and found that it is possible to detect illumination signals as small as $\sim 1 \times 10^{-16}$ W
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3 with a bandwidth of 1 Hz (see Supporting Information Figure S9 for additional details). This
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5 translates to a specific detectivity $D^* \sim 10^{12}$ Jones ($\text{cm Hz}^{1/2} \text{W}^{-1}$).
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8 This high value for the photoresponsivity of our devices is another indication that the
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10 photocurrent is originated by the GNR film, since the maximum value reported for pristine
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12 graphene is 8 orders of magnitude lower³¹. Efficient mechanisms for light absorption and current
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14 multiplication have been predicted for ultra-small GNRs^{13-15,32}. However, the key ingredient of our
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16 architecture is the use of graphene electrodes, resulting in a more efficient current
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18 injection/extraction with respect to previously reported GNRs-based devices employing metal
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20 electrodes¹⁶. Also the fact that the contact regions are directly exposed to the incoming light (and
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22 not below electrodes of thickness of several tens of nanometer) certainly plays an important role
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24 in the increased responsivity. Finally, it is worth to stress the use of a film of flatly lying GNRs
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26 grown by a surface-assisted method⁹, avoiding their aggregation, to maximize the interaction with
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28 the electrodes and obtain good electrical contacts.
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35 **Time dependence of the photocurrent.** In Figure 5b we present the time-resolved
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37 measurements of the photocurrent, by showing the temporal evolution of the drain current when
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39 switching on and off the light source. We found that the current has a rise time of typically ~ 25
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41 ms and decays back to the original value in ~ 75 ms after the light is turned off. Our results can be
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43 interpreted by considering the presence of charged defects, which trap the photo induced holes
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45 allowing for the extraction of multiple electrons for every incident photon thus contributing to the
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47 photocurrent, further enhancing the sensitivity of the devices. When the light is switched off, the
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49 carriers are released back to the circuit and the current decays back to the initial value at timescales
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51 which depend on the characteristic lifetimes of these long-lived states. Our response times are in
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3 line with other reported low-dimensional devices, where the presence of trap states contributes to
4 the gain mechanism, showing typical timescales in the range 10 ms - 1 s^{27,33-34}.

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8 The presence of charge traps can explain the saturating behavior of the responsivity shown in
9 Figure 5a, since increasing the incident power leads to the saturation of these long-lived states, and
10 a consequent decrease of the photodetection efficiency and responsivity. A further indication of
11 the presence of defect states is suggested by the observation of slow relaxation times in the I_{ds} vs
12 V_g measurements when the device is not illuminated, which is shown in the Supporting Information
13 (Figure S12). The defects may be present in the substrate or the device itself, most likely at the
14 ribbon-ribbon and ribbon-graphene junctions. For the sake of completeness, in the Supporting
15 Information (Section 6, Figures S10 and S11) we present another device showing similar
16 photoresponsivity but slower response times. This suggests that different types of defects, with
17 different lifetimes, may be present, presumably originated from the fabrication and transfer
18 processes. Admittedly, while the sensitivity of our devices compares well even with state-of-the-
19 art semiconductors devices (for comparison, commercial Si-based photodetectors have a NEP of
20 $\sim 10^{-14}$ W/Hz^{-1/2}³⁵) the relatively slow response time may limit their practical applications.
21 Nevertheless, usage in applications where high sensitivity is desired even at the expense of a fast
22 response time can be envisaged. Further device engineering will lead to improved fabrication and
23 lower defects density, in order to achieve faster photodetection. For instance, considerable
24 improvement can be obtained by adopting the clean transfer techniques developed for the van der
25 Waals heterostructures^{36,37}.

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4. CONCLUSIONS

To summarize, we presented a novel type of phototransistor device, made of bottom-up CVD-grown GNRs as the channel material and multilayer graphene as the electrodes. Our findings show the possibility to realize opto-electronic platforms fully based on graphene-based materials, where elements with different functionalities are integrated. GNR-based devices, with the chance of precisely tailoring their properties by modulating the monomer structures, hold great promise for the next generation of nano opto-electronics devices, in particular in fields where high light sensitivity is required.

FIGURES

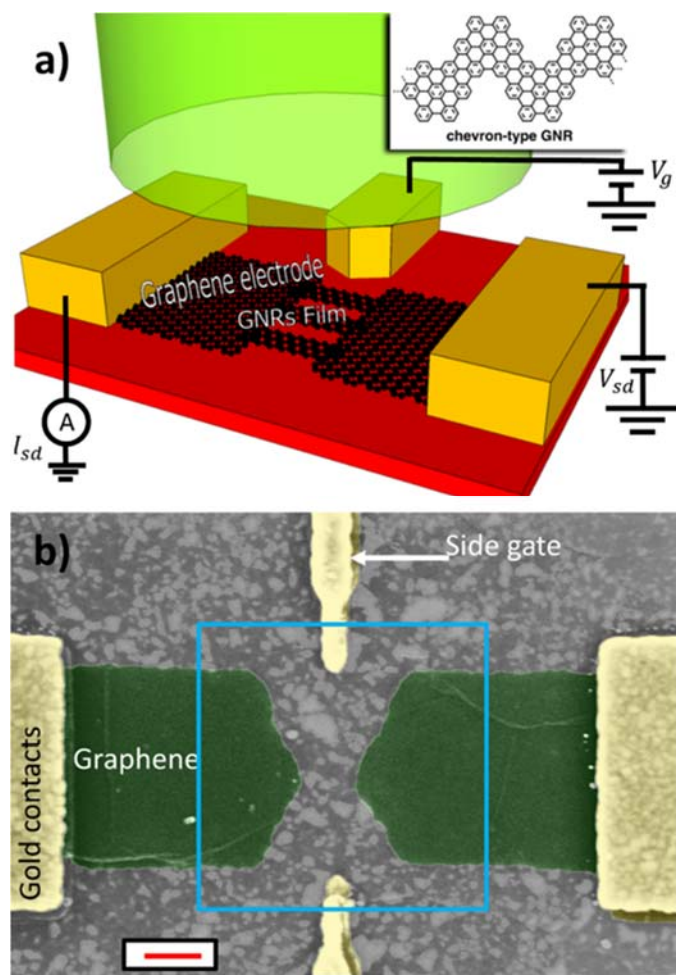


Figure 1. a) Schematic view and b) false-colour SEM image of a device made of the graphene nanoribbon channel (not visible at the SEM) and multilayer epitaxial graphene electrodes, grown on the C-face of SiC. Graphene = green; metal (Cr/Au) electrodes and lateral gate = (yellow); The inhomogeneities present in the substrate are a product of the GNRs transfer process. The scale bar is 200 nm.

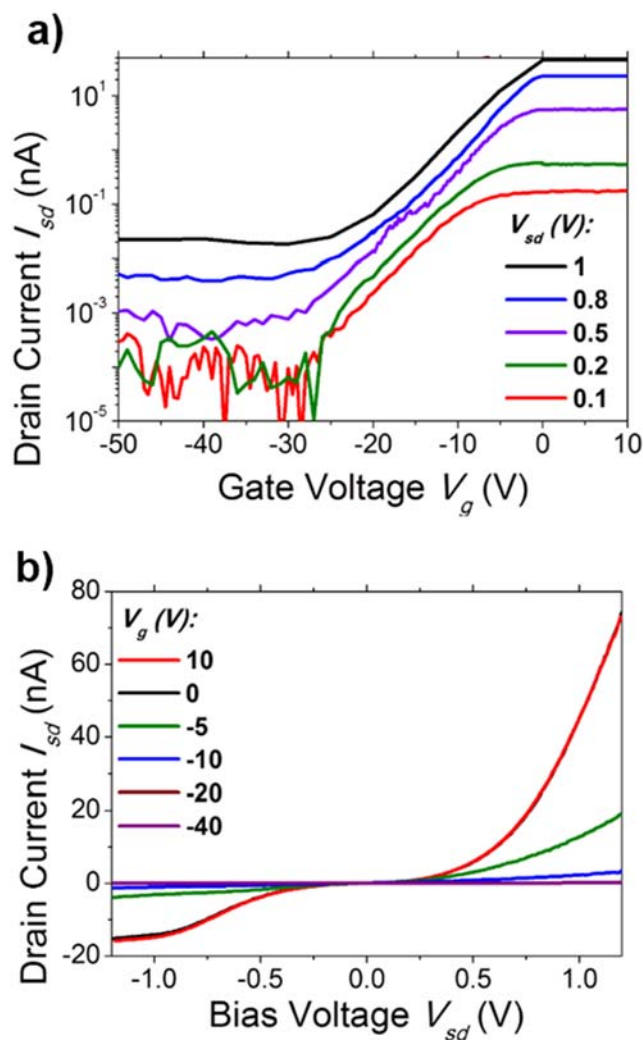


Figure 2. Room-temperature field-effect transistor characteristics, measured under illumination with a white lamp and in vacuum (10^{-4} torr). a) Gate voltage dependence of the current shown for various bias voltages. b) Corresponding I_{sd} - V_{sd} characteristics shown for different gate voltages.

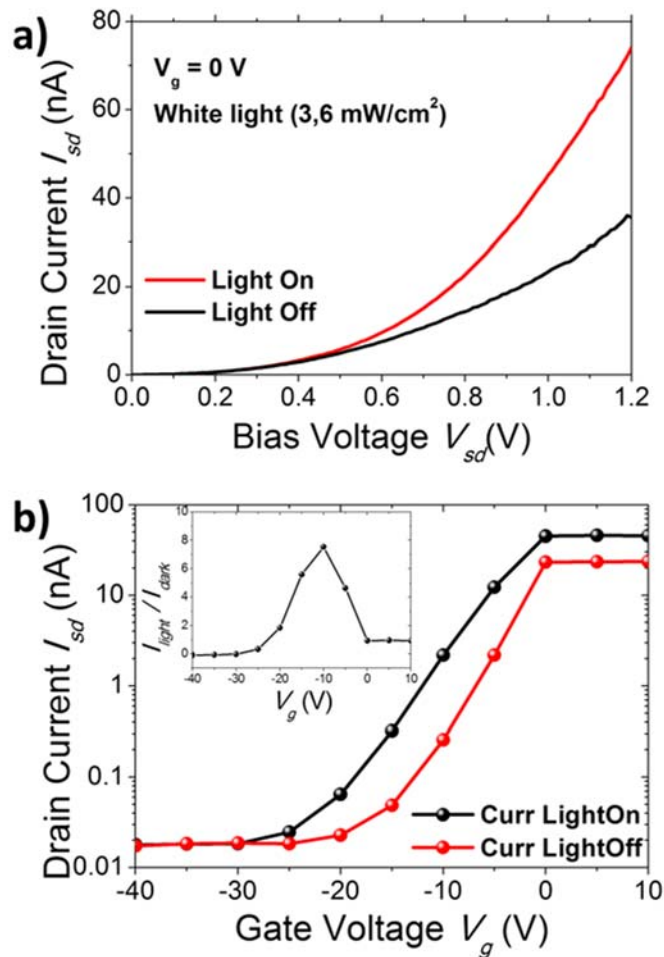


Figure 3. a) Current output characteristics of the device with and without illumination with a white lamp (power of 3.6 mW cm⁻² measured at $\lambda = 550$ nm). b) Gate voltage dependence of the photocurrent as shown in (a) fixing the bias voltage at 1 V. For each point, the current is measured firstly under illumination (I_{light}), then the light is switched off (I_{dark}). The insert shows the ratio between the two measured values for each gate point.

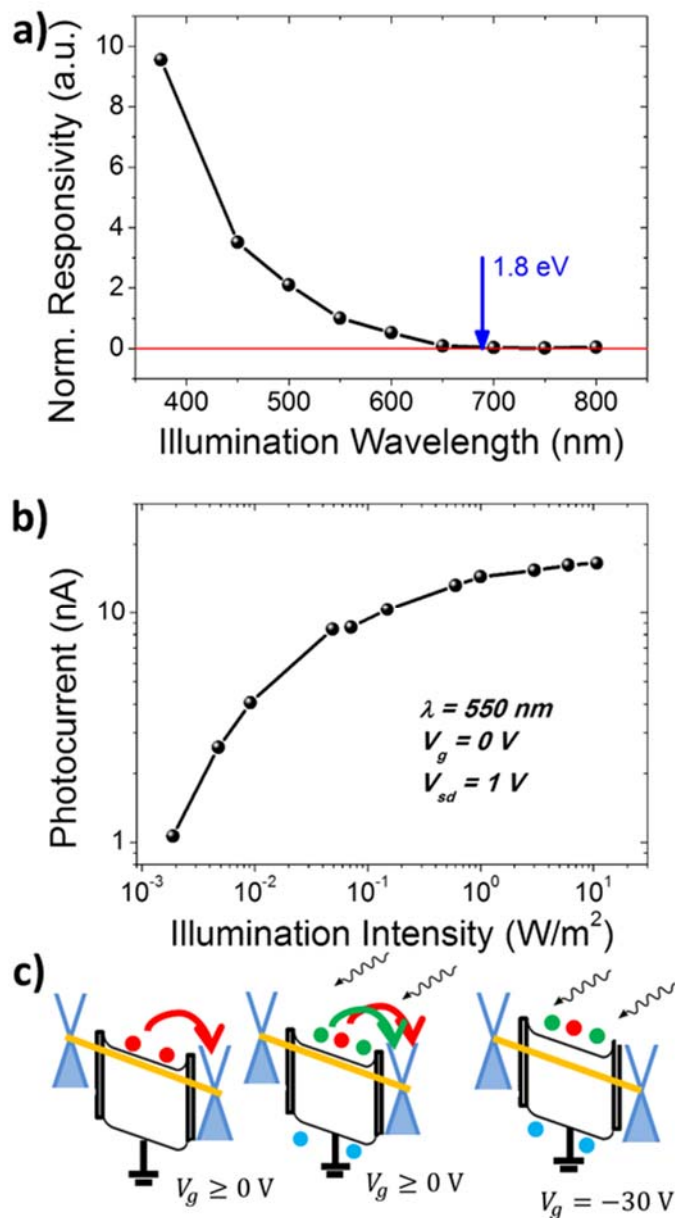


Figure 4. a) Normalized photoresponsivity ($I_{\text{photo}} / P_{\text{inc}} = (I_{\text{light}} - I_{\text{dark}}) / P_{\text{inc}}$, setting the value at $\lambda = 550 \text{ nm}$ equal to 1) of the device as a function of the photon wavelength λ . b) Photocurrent versus light intensity at a fixed bias voltage of 1 V and gate voltage of 0 V, with $\lambda = 550 \text{ nm}$. (c) Schematic model for the functioning of the GNR devices with graphene electrodes: the right panel represents the ON state ($V_g \geq 0 \text{ V}$ and finite V_{sd}) in the dark. In the central and right panels a light source of energy larger than the GNRs bandgap illuminate the sample. In the central panel

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3 $V_g \geq 0$ V, while in the right panel the device is in the OFF state ($V_g < -30$ V). Red balls are the
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5 intrinsic carriers in the GNR channel, green-blue balls are the photogenerated electron-hole pairs.
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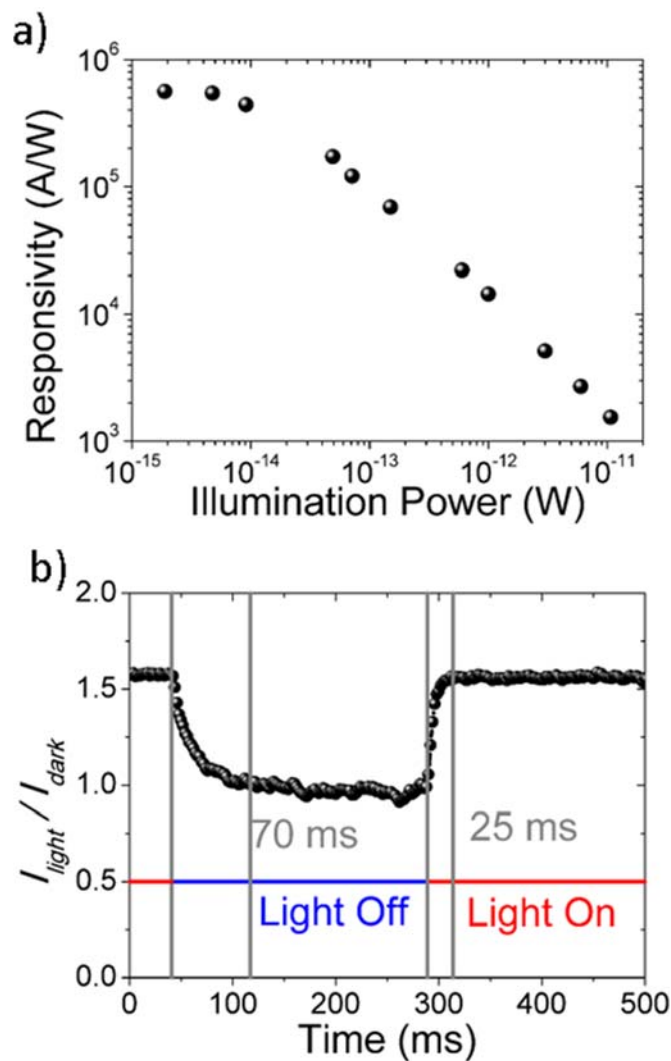


Figure 5. a) Photoresponsivity of the device under monochromatic illumination ($\lambda = 550\text{nm}$) for different incidence power values. This is calculated considering an active area equal to $1 \times 1 \mu\text{m}^2$ as shown in Figure 1(b). b) Time-resolved photocurrent of the device, measured fixing the source-drain bias voltage to 1 V and the gate voltage to 0 V. The illumination is provided by a white lamp ($P \sim 0.5 \times 10^{-12}$ W). The rise and fall times are indicated as the time needed to reach 95% of the steady state value.

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3 ASSOCIATED CONTENT
4
56 **Supporting Information.**
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10 The Supporting Information is available free of charge via the Internet at <http://pubs.acs.org>.
11 Scheme of the CVD synthesis of the GNRs and absorption measurement. Characterization of the
12 pristine graphene devices (without gap and before the GNR transfer). Raman characterization of
13 the GNRs after the transfer on the multilayer graphene electrodes. Additional electrical
14 characterization for the device presented in the main text and other devices with similar
15 characteristics. Evaluation of the noise equivalent power.
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26 AUTHOR INFORMATION
2728
29 Corresponding Author
3031
32 *andrea.candini@nano.cnr.it Phone: +39 059 2058376
33
3435 Note
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